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Fig. 1a

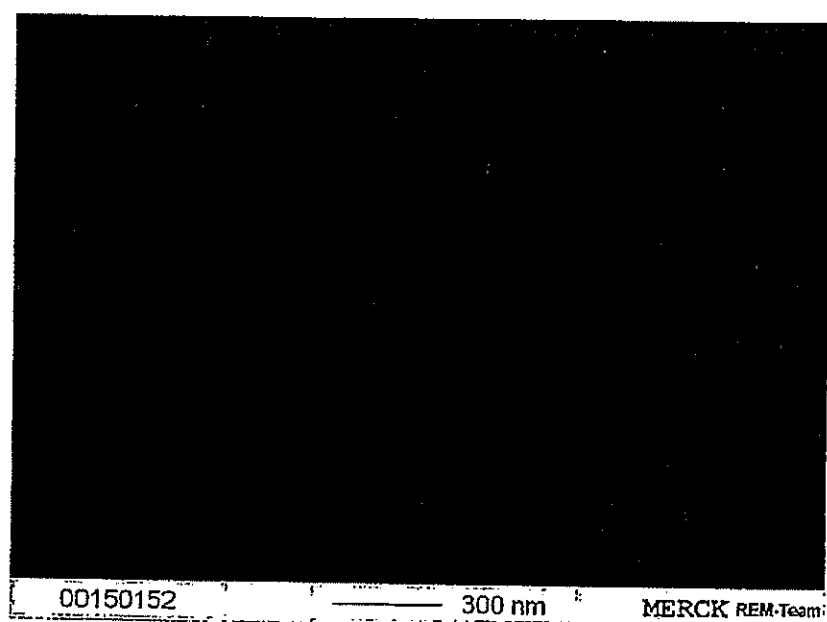
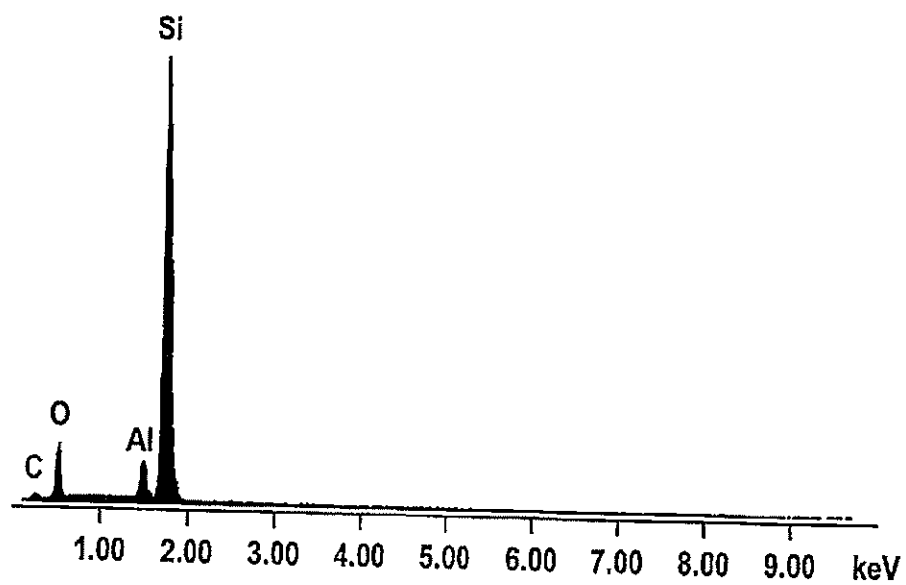


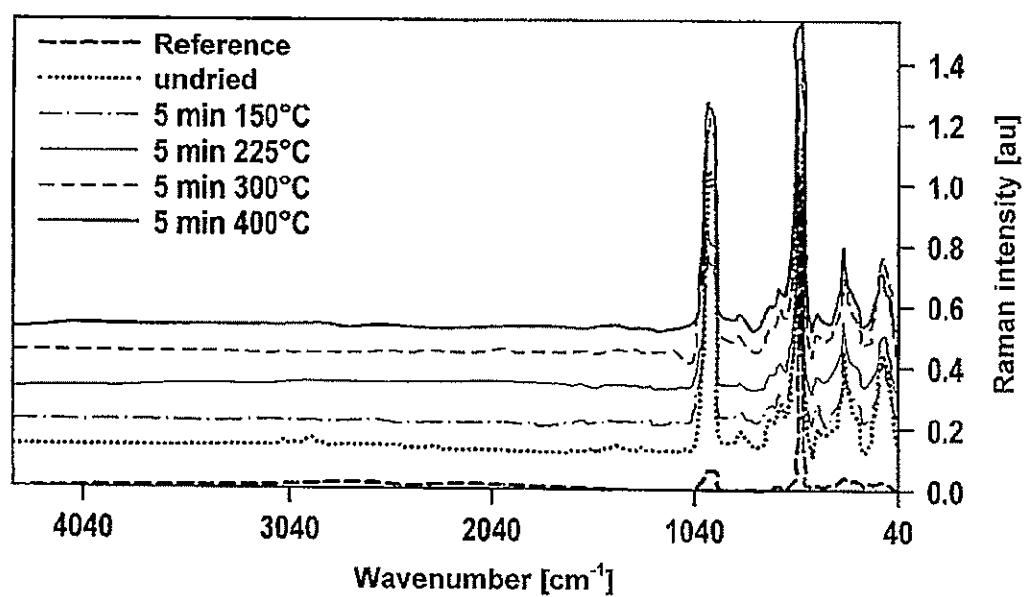
Fig. 1b

Label A: Wafer Al



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Fig. 2



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Fig. 3a

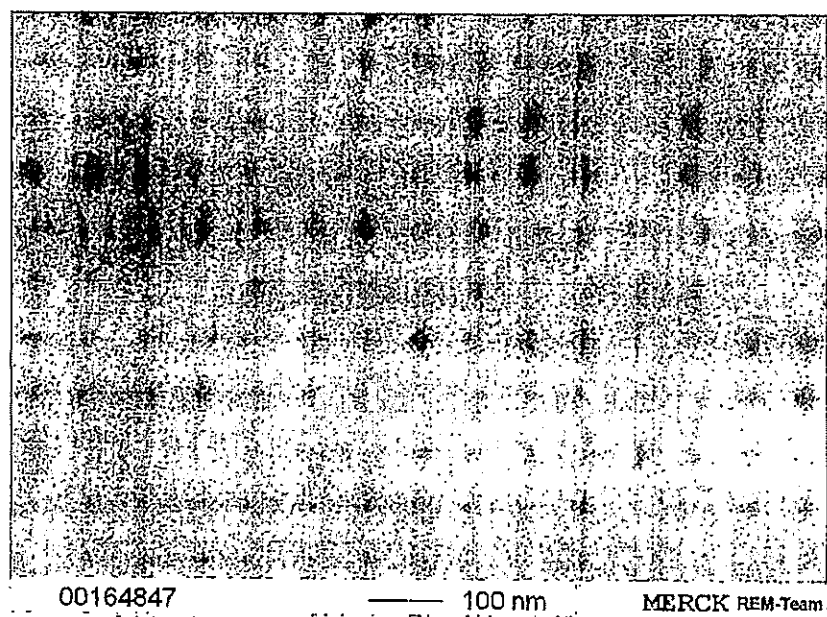
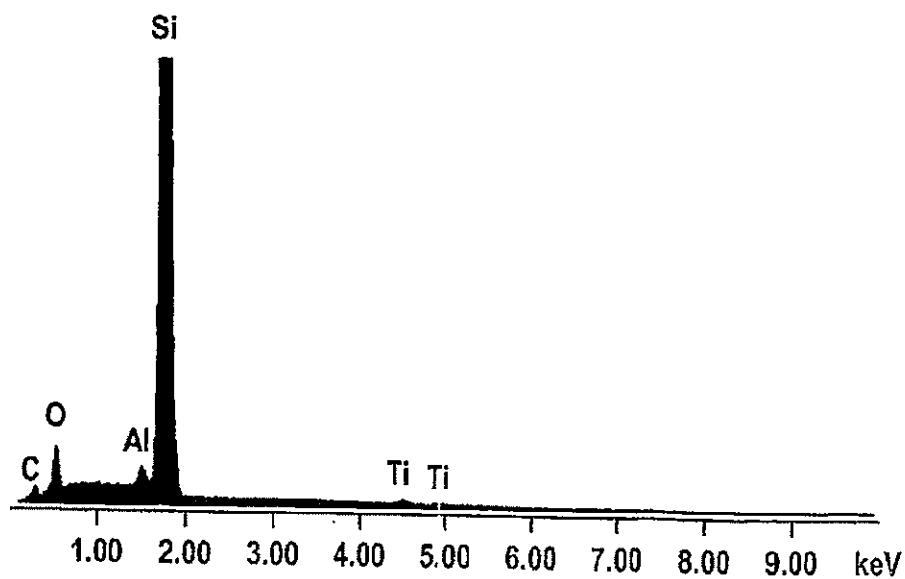


Fig. 3b

Label A: Wafer AlTi5



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Fig. 4a

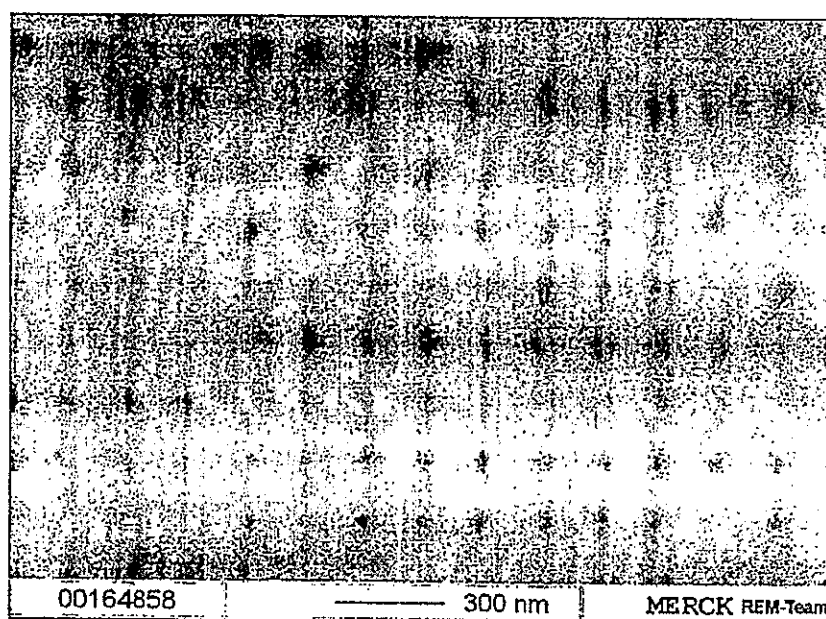
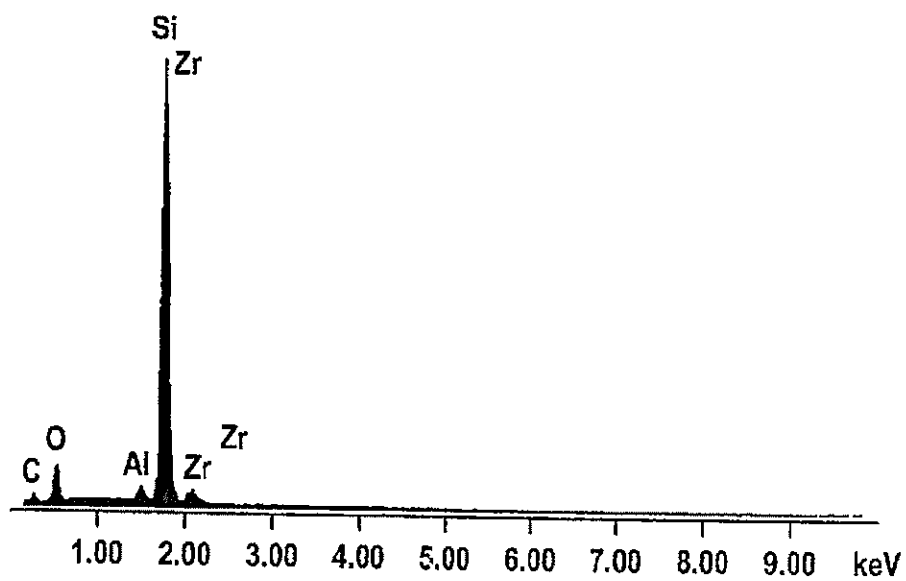


Fig. 4b

Label A: Wafer AlZr2



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Fig. 5

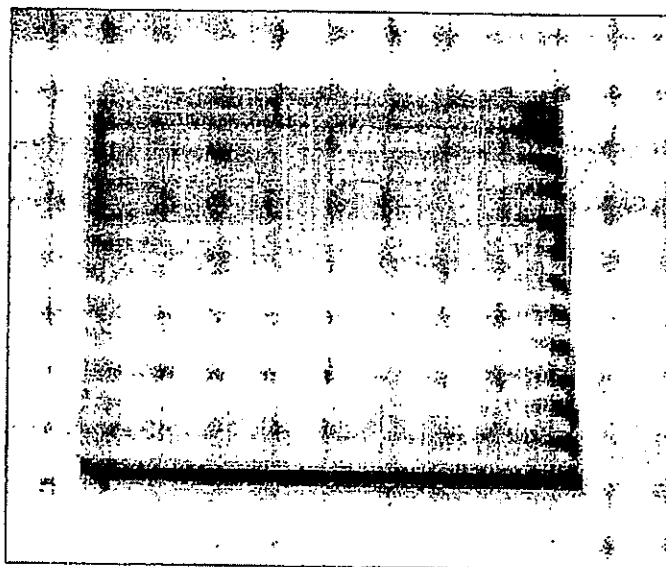
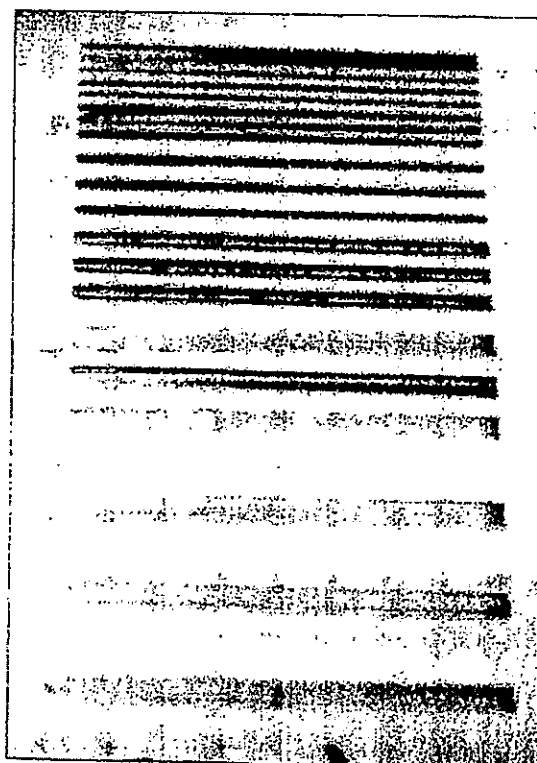


Fig. 6



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Fig. 7

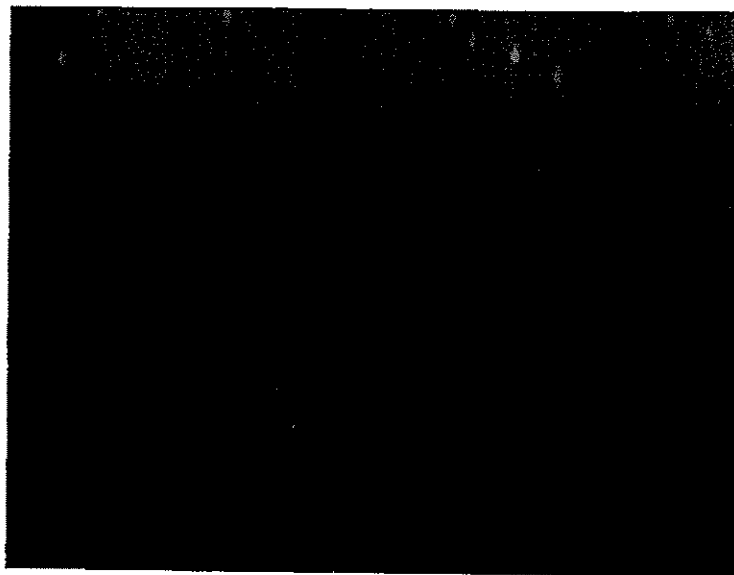
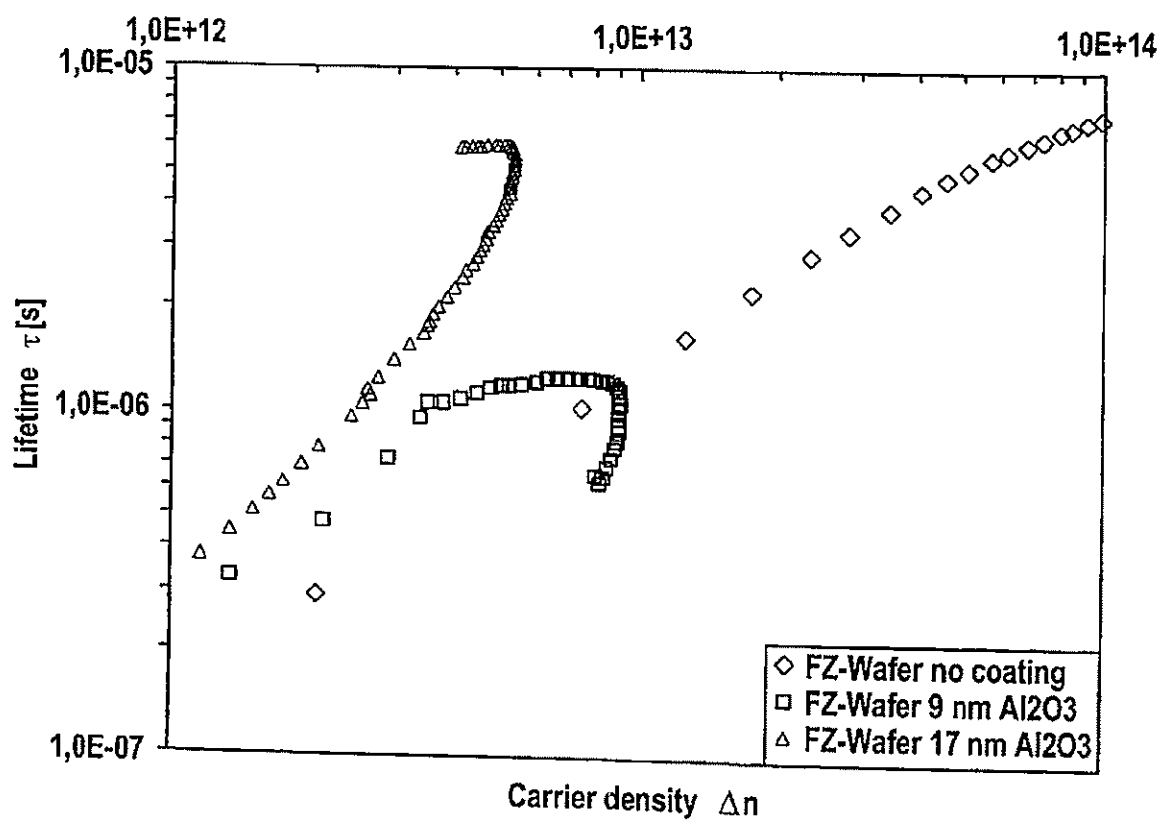
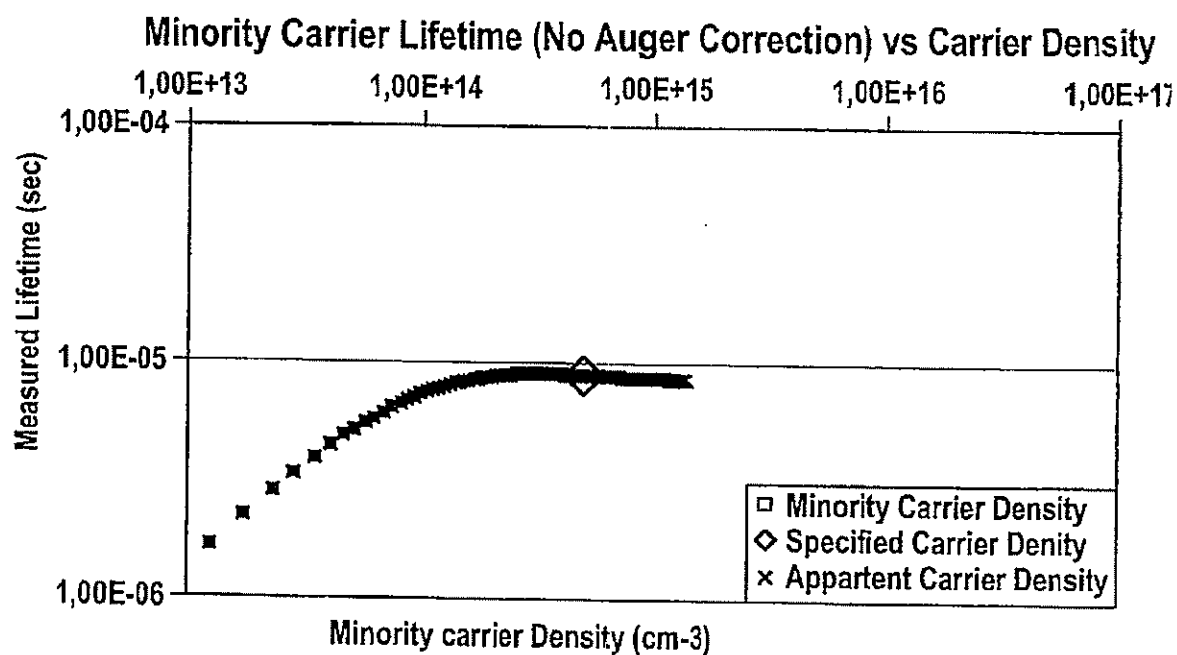
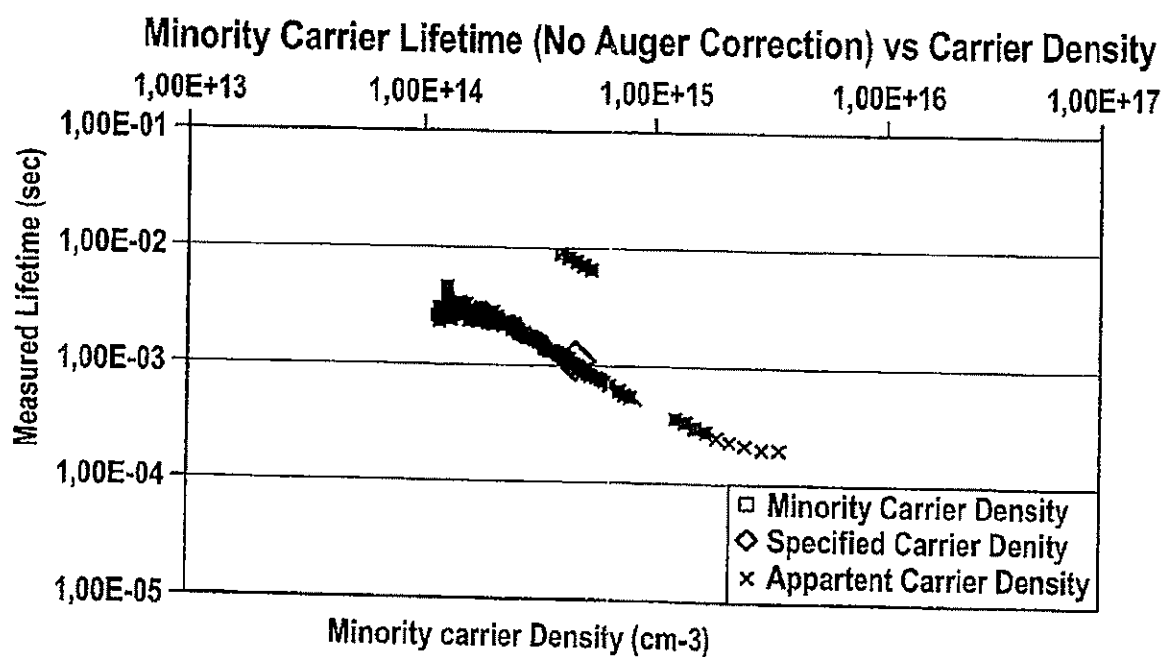


Fig. 8

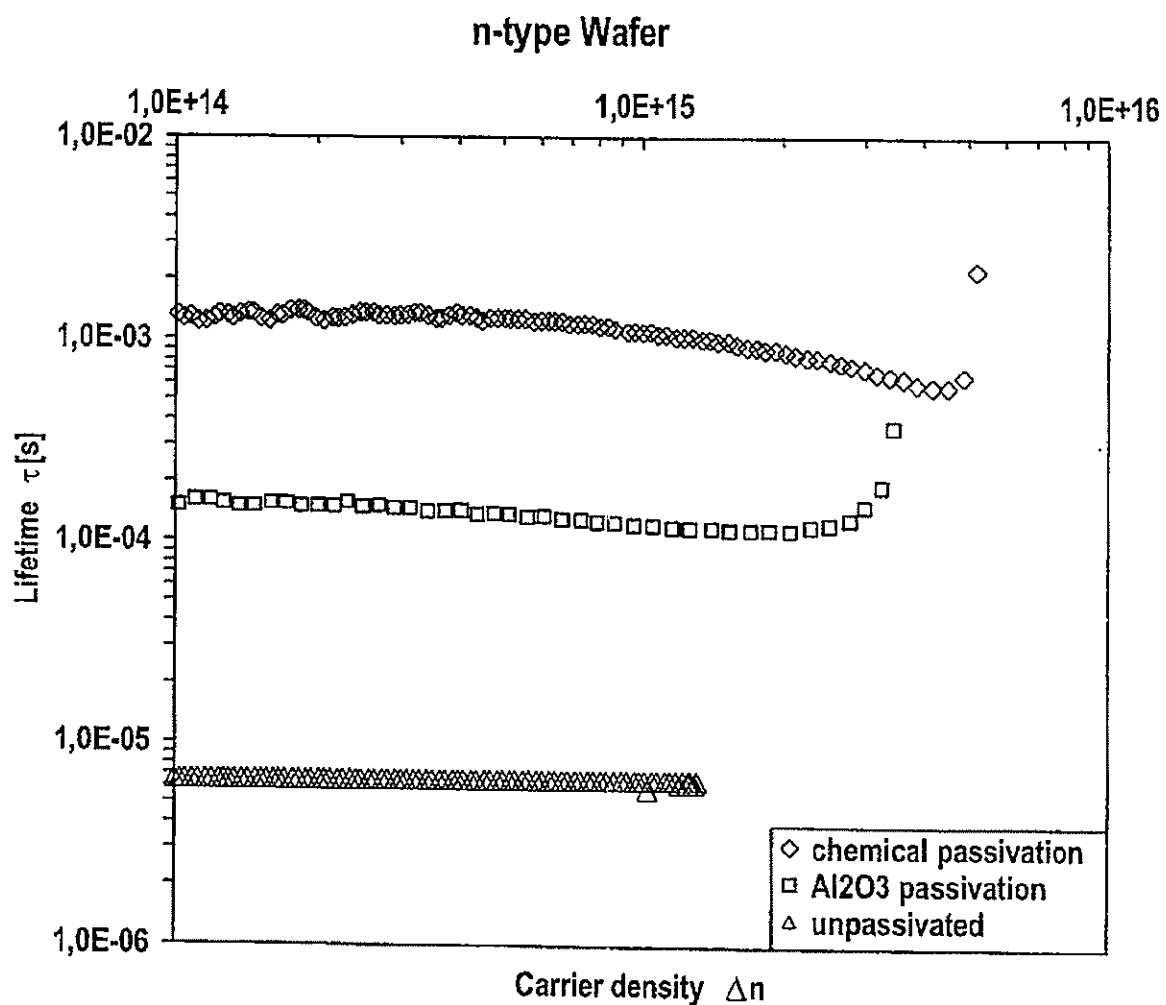


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Fig. 9a**Fig. 9b**

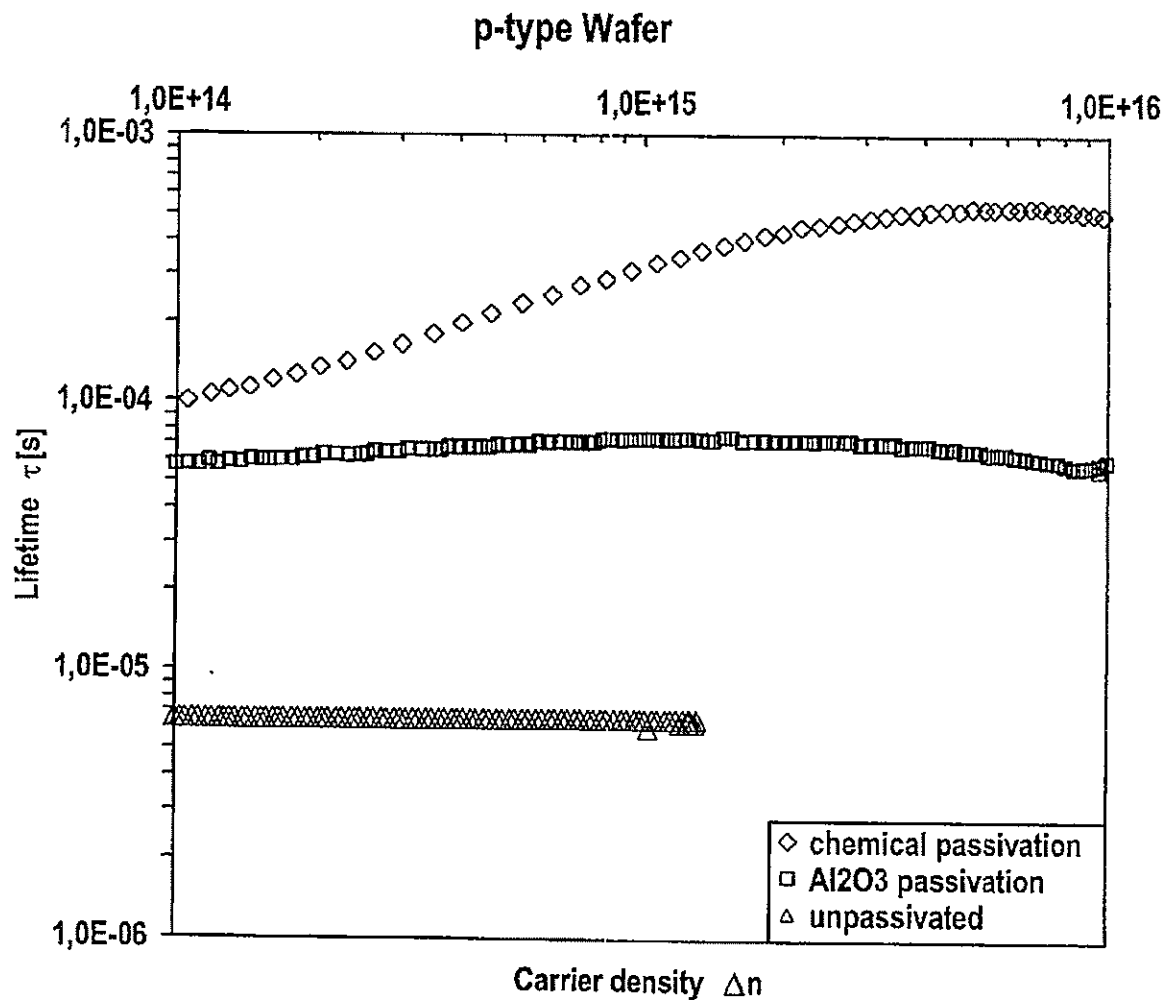
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Fig. 10



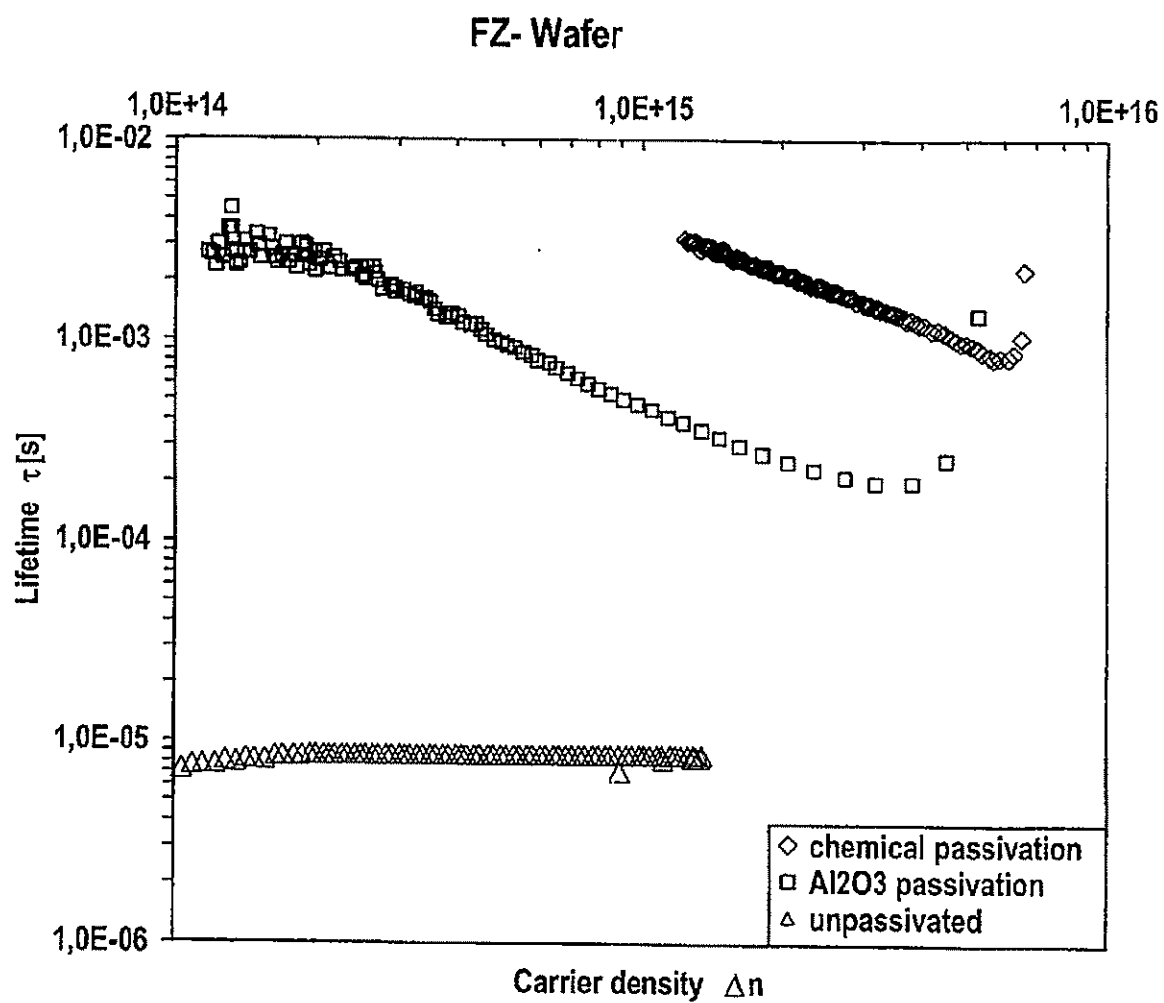
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Fig. 11



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Fig. 12



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Fig. 13

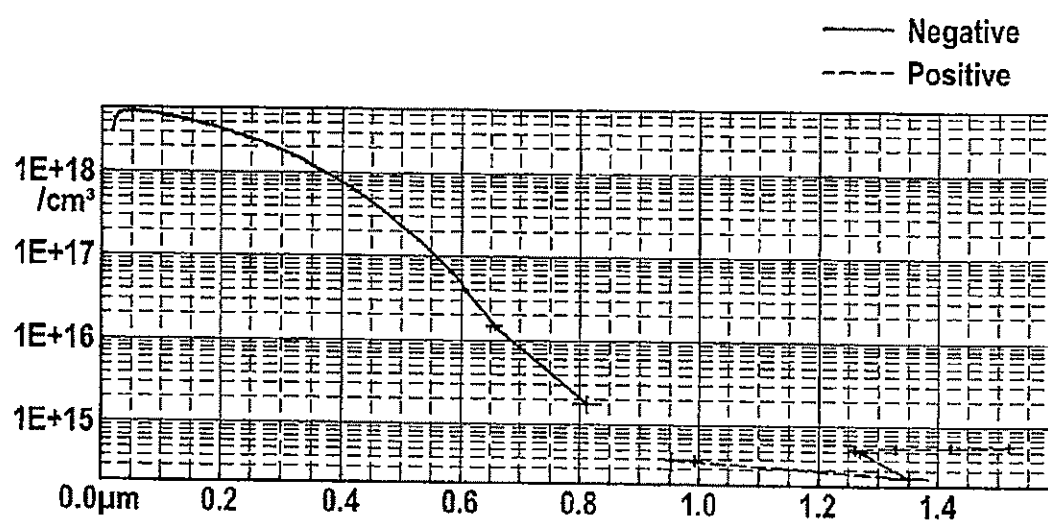
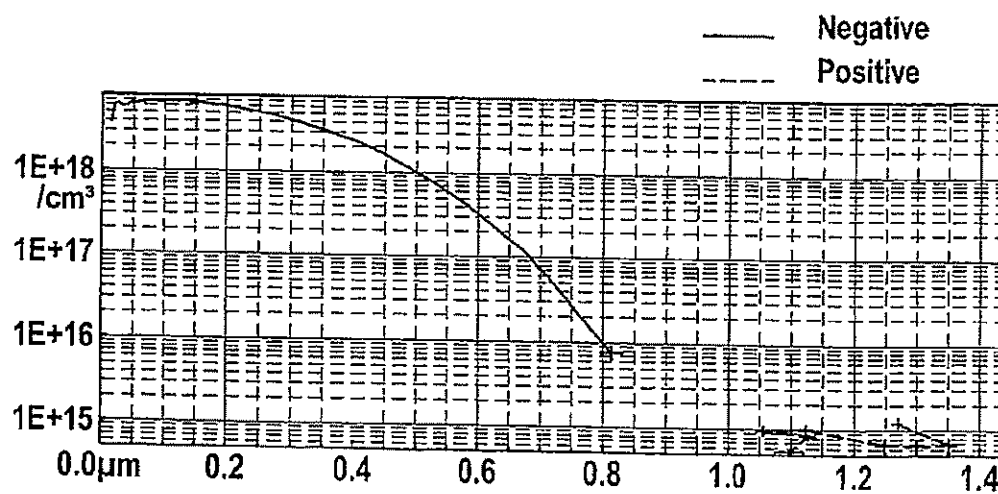


Fig. 14



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Fig. 15

